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|---------------------------------------|---|
| Date                                  | 7 August 2002   |
| Our File                              | 42121-0003  |
| To<br>Company<br>Fax number           | Examiner Cybille Delacroix-Muirheid<br>United States Patent and Trademarks Office<br>(703) 308-4242               |
| From<br>Direct Dial<br>E-mail         | Mitchell B. Charness<br>(613) 566-2052<br>mcharness@ridoutmaybee.com  |
| Number of pages<br>including this one | 12  |
| Original                              | <input type="checkbox"/> By Mail <input type="checkbox"/> By Courier <input checked="" type="checkbox"/> Not Sent |

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Message

PLEASE CONTACT PATRICIA ZAHAVICH AT (613) 236-1995 IF YOU HAVE  
ANY QUESTIONS OR COMMENTS REGARDING THIS TRANSMISSION

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File: 42121-0003 MHM:pdz

**IN THE UNITED STATES PATENT AND TRADEMARKS OFFICE**

In The Matter of Patent Application:

Applicant : LAUTT, Wayne W.  
Serial No. : 09/806,989  
Filing Date : May 29, 2001  
Title : METHOD FOR TREATING INSULIN RESISTANCE  
THROUGH HEPATIC NITRIC OXIDE  
Examiner : Cybille Delacroix-Muirheid  
Unit: : 1614  
Paper No. : 12

#13B  
9/18/02  
OFFICIAL**RESPONSE AND AMENDMENT**

To: The Assistant Commissioner for Patents,  
The U.S. Department of Commerce,  
PATENT OFFICE,  
Washington, D.C., U.S.A., 20231

Dear Sir:

This is in reply to the Office Action mailed 16 July 2002 in the application identified above.

Please amend the application as follows: